

FORM PTO-1449
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06223P USA

SERIAL NO.

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(Use several sheets if necessary)

APPLICANT

Steven Gerard Mayorga, et al.

FILING DATE

GROUP

(37 CFR 1.98(b))

U.S. PATENT DOCUMENTS

EXAM- INER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPRO- PRIATE
hgm	5 0 2 8 5 6 6	7/2/91	Andre Lagendijk	437	238	7/27/90
	5 5 4 8 0 0 6	8/20/96	Satao Hirabayashi, et al	524	82	11/17/94
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	3 3 4 4 1 1 1	9/26/67	Alan J. Chalk	260	46.5	9/26/66
	3 8 8 2 0 8 3	5/6/75	Abe Berger, et al	260	46.5	11/21/73
	3 9 9 8 8 6 5	12/21/76	George Siciliano, et al	260	448.2	3/12/75
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	6 3 6 8 3 5 9	4/9/02	R. J. Perry, et al	8	142	12/17/99

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DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
7 1 4 5 1 7 9	8/25/99	JP	C07F	7/21	YES NO
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

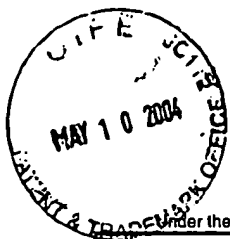
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	JP 07 145179 A: Patent Abstracts of Japan, vol. 1995, No. 09, 10/31/95.
	XP-002233220: Derwent Publications Ltd., London, GB; AN 1980-10616C.
	XP-002233221: Derwent Publications Ltd., London, GB; AN 1997-72075Y.

EXAMINER

DATE CONSIDERED

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PTO/SB/08A (08-03)
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Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Complete if Known	
				Application Number	10/602,279
				Filing Date	23 June 2003
				First Named Inventor	Steven Gerard Mayorga, et al.
				Art Unit	1712
Examiner Name					
Sheet	1	of	1	Attorney Docket Number	06223P USA

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
TJM		US- 2004/0039219 A1	2/26/2004	Tianniu Chen, et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				

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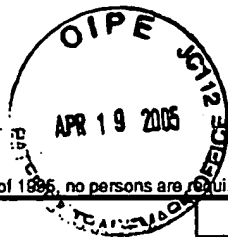
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		Number-Kind Code ² (if known)			
mm		US- 2004/0039219	02/26/2004	Tianniu Chen, et al	
		US- 2003/0149213	08/07/2003	Steven Gerard Mayorga, et al	
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		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
mm		WO 02/43119	05/30/2002	International Business Machines Corp.		✓

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